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SERIAL NUMBER 10/509,230	FILING OR 371(c) DATE 09/24/2004 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. SON-2628
APPLICANTS Shinji Omori, Kanagawa, JAPAN; Kaoru Koike, Ibaraki, JAPAN; Shigeru Moriya, Kanagawa, JAPAN; Isao Ashida, Kanagawa, JAPAN;				
** CONTINUING DATA <i>noted</i> This application is a 371 of PCT/JP03/03455 03/20/2003				
** FOREIGN APPLICATIONS <i>noted</i> JAPAN 2002-92612 03/28/2002				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met met Verified and Acknowledged <i>Signature</i> Examiner's Signature Initials		STATE OR COUNTRY JAPAN	SHEETS DRAWING 24	TOTAL CLAIMS 26
		INDEPENDENT CLAIMS 5		
ADDRESS 23353				
TITLE Mask pattern correction method, semiconductor device manufacturing method, mask manufacturing method and mask				
FILING FEE RECEIVED 1200	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	